

Transaction Information

ToolId	FM01
ToolStatus	Connected
Location	East Fishkill, NY
WaferSize	300 mm
FabSection	Etch

General Product Information

VendorSupplier	SHIBAURA
Model	ALLEGRO CDE 300
Vintage	2005
SerialNo	ATP0014
AssetDescription	FM01 SHIBAURA 2 Chamber
SoftwareVersion	5.73 B9
CIM	Secs Gem
Process	Dry Etch

Hardware Configuration (Fab)

SystemType	Description	Quantity	Status
Main System	Mainframe,	1	OK
Main System	Transfer Chamber	1	OK
Main System	Etch chambers, Chamber	2	OK
Factory Interface	FOUP	2	OK
Handler System	Vacuum Robot	1	OK
Handler System	Atmospheric Robot	1	OK
Options System			
Others			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
Chiller	2	OK
A-Box	1	OK

Missing/Faulty Parts / Accesories List

Description	Quantity
CH 1 ESC Coolant plate and connections	1

Tool Pictures

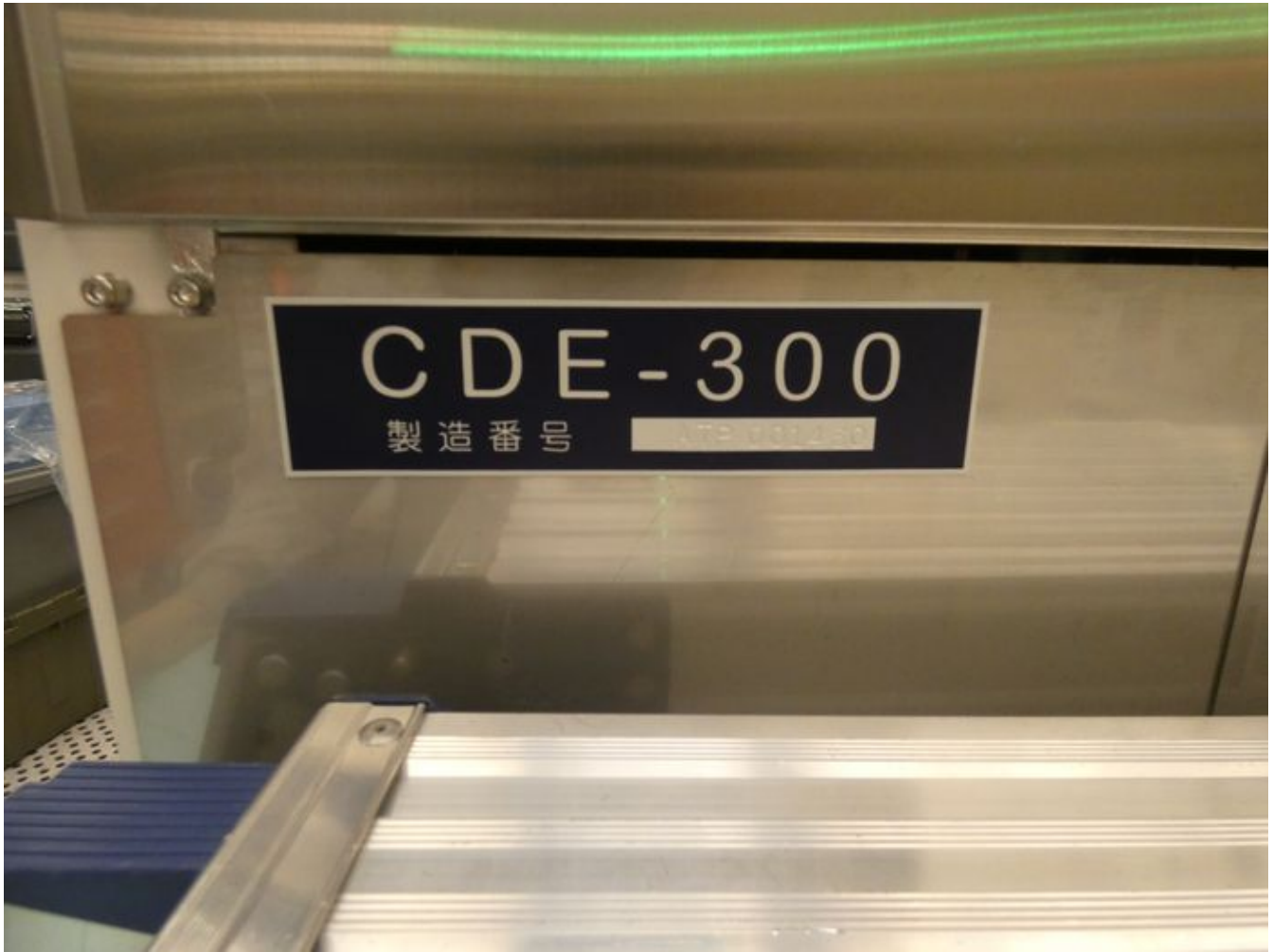
general

TOOLFRONT VIEW



manufactureserial

Serial Plate



Additional Configuration Files